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**CONFIRMATION NO. 8129** 

Allowance 1/2 COUNTRY DRAWING CLAIMS CLAIMS Acknowledged Examiner's Signature Initials DRAWING CLAIMS CLAIMS 2  ADDRESS Rabin & Berdo, P.C. Suite 500 1101 14th Street, N.W. Washington , DC 20005  TITLE Production process for semiconductor device  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:  FILING FEE	Dip Data Gliect		•								
Junichi Hikita, Kyoto, JAPAN;  Kazutaka Shibata, Kyoto, JAPAN;  Shigeyuki Ueda, Kyoto, JAPAN;  "CONTINUING DATA "This application is a DIV of 09/511,800 02/23/2000 PAT 6,696,347  This application is a DIV of 09/511,800 02/23/2000 PAT 6,696,347  "FOREIGN APPLICATIONS "JAPAN 11-045214 02/23/1999  JF REQUIRED, FOREIGN FILING LICENSE GRANTED "O4/28/2004  Foreign Priority claimed Succ 119 (a-d) conditions "Japan Indiana" STATE OR SHEETS TOTAL INDEPENDENT Met Verified and Acknowledged Examiner's Signature Initials COUNTRY DRAWING CLAIMS CLAIMS 2  ADDRESS Rabin & Berdo, P.C. Suite 500  1101 14th Street, N.W. Washington , DC 20005  TITLE Production process for semiconductor device  FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT   Day In Fees (Processing Ext. of time)		SERIAL NUMBER 12/31/2003 10/748,327						r unit	DOCKET NO.		
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